

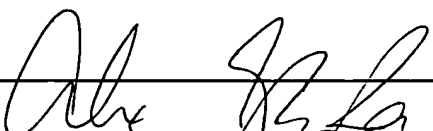
<p>FORM HDP-1449 (Based on Form PTO-1449)</p> <p>PATENT AND TRADEMARK OFFICE</p> <p>INFORMATION DISCLOSURE CITATION</p> <p>(Use several sheets if necessary)</p> <p>Sheet 1 of 1</p>	ATTORNEY DOCKET No.	SERIAL No.
	9319S-000311/CPA	10/006,794
	APPLICANT	
	Hitoshi FUKUSHIMA	
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	December 4, 2001	2812

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(if appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation *	
						Yes	No
1.	AC	10-217457A	08/18/1998	Japan			X
2.		99/038695	08/05/1999	WO			X
3.		11-15000	01/22/1999	Japan			X
4.	AC	8-88402	04/02/1996	Japan			X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.	AC	H. Fukushima and 2 others, "Microstructure, Wettability, and Thermal Stability of Semifluorinated Self-Assembled Monolayers (SAMs) on Gold" J. Phys. Chem. B 2000, 104, pp. 7417-7423
2.	AC	Notification of Reasons of Rejection dated June 8, 2005 in corresponding Japanese application No. JP2001-370544.

*One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at www.ipo.go.jp

Examiner:		Date Considered:	7/16/06
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